

SILICON PLANAR EPITAXIAL HIGH-SPEED DIODE

Silicon epitaxial high-speed diode in a microminiature plastic envelope. It is intended for high-speed switching in hybrid thick and thin-film circuits.

QUICK REFERENCE DATA

Continuous reverse voltage	V_R	max.	75 V
Repetitive peak reverse voltage	V_{RRM}	max.	85 V
Repetitive peak forward current	I_{FRM}	max.	500 mA
Junction temperature	T_j	max.	150 °C
Forward voltage at $I_F = 50$ mA	V_F	<	1,0 V
Reverse recovery time when switched from $I_F = 10$ mA to $I_R = 10$ mA; $R_L = 100 \Omega$; measured at $I_R = 1$ mA	t_{rr}	<	6 ns
Recovery charge when switched from $I_F = 10$ mA to $V_R = 5$ V; $R_L = 500 \Omega$	Q_s	<	45 pC

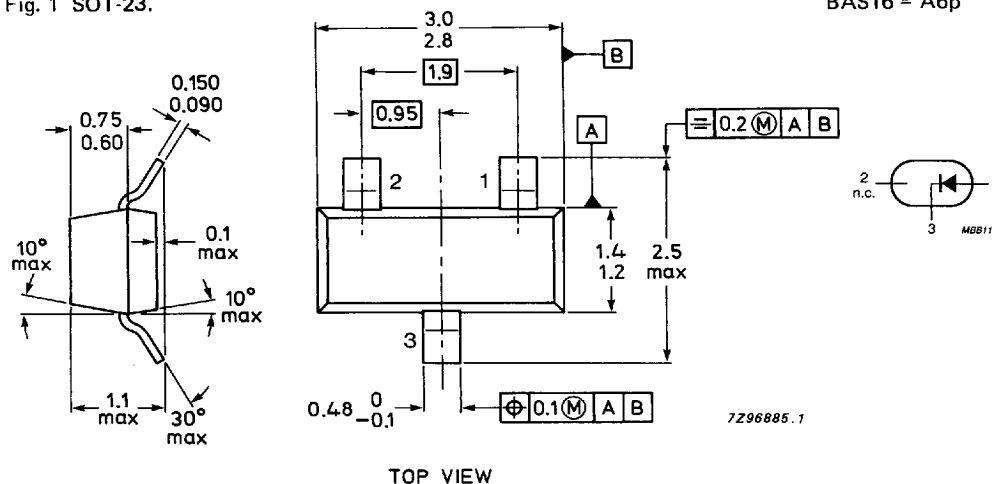
MECHANICAL DATA

Dimensions in mm

Marking code

Fig. 1 SOT-23.

BAS16 = A6p



See also *Soldering recommendations*.

RATINGS

Limiting values in accordance with the Absolute Maximum System (IEC 134)

Continuous reverse voltage	V_R	max.	75 V
Repetitive peak reverse voltage	V_{RRM}	max.	85 V
Average rectified forward current* (averaged over any 20 ms period) up to $T_{amb} = 25^\circ\text{C}$	$I_F(AV)$	max.	250 mA
Forward current (DC)	I_F	max.	250 mA
Repetitive peak forward current	I_{FRM}	max.	500 mA
Non-repetitive peak forward current (per crystal)			
$t = 1\ \mu\text{s}$	I_{FSM}	max.	2 A
$t = 1\ \text{ms}$	I_{FSM}	max.	1 A
$t = 1\ \text{s}$	I_{FSM}	max.	0,5 A
Storage temperature range	T_{stg}	-65 to +150	$^\circ\text{C}$
Junction temperature	T_j	max.	150 $^\circ\text{C}$

THERMAL RESISTANCE**

From junction to ambient [▲]	R_{thj-a}	=	430 K/W
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CHARACTERISTICS $T_j = 25^\circ\text{C}$ unless otherwise specified.

Forward voltage

$I_F = 1\ \text{mA}$	V_F	<	715 mV
$I_F = 10\ \text{mA}$	V_F	<	855 mV
$I_F = 50\ \text{mA}$	V_F	<	1000 mV
$I_F = 150\ \text{mA}$	V_F	<	1250 mV

Reverse current

$V_R = 25\ \text{V}; T_j = 150^\circ\text{C}$	I_R	<	30 μA
$V_R = 75\ \text{V}$	I_R	<	1 μA
$V_R = 75\ \text{V}; T_j = 150^\circ\text{C}$	I_R	<	50 μA

Diode capacitance

$V_R = 0; f = 1\ \text{MHz}$	C_d	<	2 pF
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Forward recovery voltage (see also Fig. 2)

when switched to $I_F = 10\ \text{mA}; t_p = 20\ \text{ns}$	V_{fr}	<	1,75 V
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Reverse recovery time (see also Fig. 3)

when switched from $I_F = 10\ \text{mA}$ to $I_R = 10\ \text{mA};$ $R_L = 100\ \Omega; \text{measured at } I_R = 1\ \text{mA}$	t_{rr}	<	6 ns
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Recovery charge (see also Fig. 4)

when switched from $I_F = 10\ \text{mA}$ to $V_R = 5\ \text{V};$ $R_L = 500\ \Omega$	Q_s	<	45 pC
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* Measured under pulse conditions. $t_p \leq 0,5\ \text{ms}$. $I_F(AV) = 150\ \text{mA}$, $t(AV) \leq 1\ \text{ms}$, for sinusoidal operation.** See *Thermal characteristics*.

▲ Mounted on a ceramic substrate of 8 mm x 10 mm x 0,7 mm.

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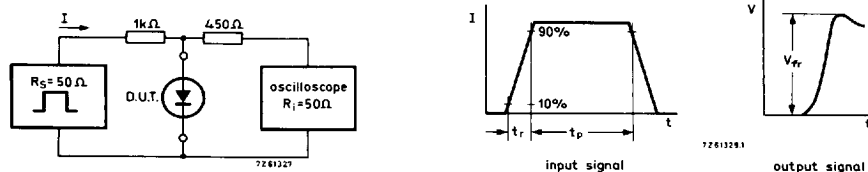


Fig. 2 Forward recovery voltage test circuit and waveforms.

Input signal: forward pulse rise time = $t_r = 20$ ns; forward current pulse duration $t_p = 120$ ns; duty factor = $\delta = 0,01$.

Oscilloscope: rise time = $t_r = 0,35$ ns.

Circuit capacitance $C \leq 1$ pF (C = oscilloscope input capacitance + parasitic capacitance).

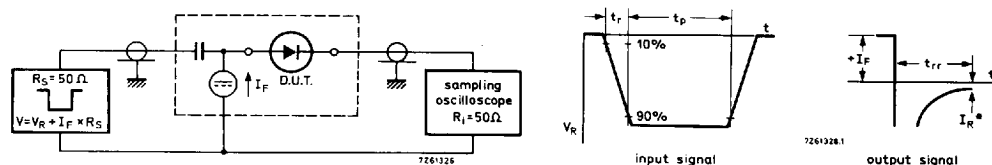


Fig. 3 Reverse recovery time test circuit and waveforms.

Input signal: reverse pulse rise time = $t_r = 0,6$ ns; reverse pulse duration = $t_p = 100$ ns; duty factor = $\delta = 0,05$.
* t_{rr} up to $I_R = 1$ mA.

Oscilloscope: rise time = $t_r = 0,35$ ns.

Circuit capacitance $C \leq 1$ pF (C = oscilloscope input capacitance + parasitic capacitance).

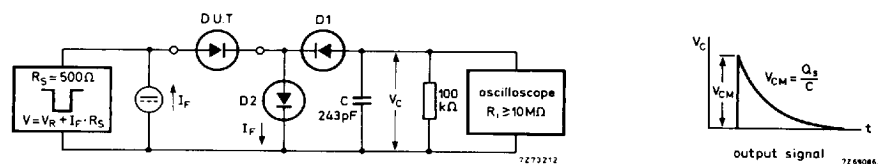


Fig. 4 Recovery charge test circuit and waveform.

D1 = BAW62; D2 = diode with minority carrier life time at 10 mA: < 200 ps

Input signal

Rise time of the reverse pulse

Reverse pulse duration

Duty factor

$$\begin{aligned} t_r &= 2 \text{ ns} \\ t_p &= 400 \text{ ns} \\ \delta &= 0,02 \end{aligned}$$

Circuit capacitance $C \leq 7$ pF (C = oscilloscope input capacitance + parasitic capacitance).

